

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

IMAI ET AL.

Atty. Ref.: 1035-650; Confirmation No. 7106

Appl. No. 10/589,390

TC/A.U. 2892

Filed: August 15, 2006

Examiner: Dang, P.T.

For: THIN FILM TRANSISTOR, METHOD OF MANUFACTURING SAME, DISPLAY  
DEVICE, METHOD OF MODIFYING AN OXIDE FILM, METHOD OF FORMING AN  
OXIDE FILM, SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE, AND APPARATUS FOR MANUFACTURING  
SEMICONDUCTOR DEVICE

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April 13, 2009

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

Responsive to the Official Action dated January 14, 2009, entry and  
consideration of the following amendments and remarks are requested.